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Date: October 21, 2002

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PATENT
36856.919

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Makoto INAI et al.

Serial No.: 09/658,732

Filed: September 11, 2000

Title: FIELD-EFFECT SEMICONDUCTOR
DEVICE

Art Unit: 2815

Examiner: B. W. Baumeister

AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated May 20, 2002, the period for response to which has been extended to October 20, 2002, by the accompanying Petition for Two-Month Extension of Time, please amend the above-identified application as follows:

IN THE CLAIMS

Please replace claims 1 and 12 with the following claims:

1. A field-effect semiconductor device comprising:

a channel layer;

a contact layer;

a semiconductor structure having an electron-affinity different from those of the channel layer and the contact layer and formed between the channel layer and the

C'